

PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

963.0040USU

Application Number

Not Yet Assigned

Applicant

Czyszczewski et al.

Filing Date

April 24, 2000

Group Art Unit

Not Yet Assigned

Jc682 U.S. PTO
09/557118

04/24/00

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JSD	4,454,575	6/12/84	Bushaw et al.	364	200	
JSD	5,530,907	6/25/96	Pavey et al.	395	889	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

10/21/03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

O-1449

Docket Number (Optional)

Application Number

963.0040USU

09/557,018

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Applicant

J. Czyszczewski et al..

SEP 13 2000

Filing Date

4/24/00

Group Art Unit

2756

TC 2700 MAIL ROOM

INFORMATION DISCLOSURE CITATION
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U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,438,433	8/1/95	Reifman et al.	358	468	
	5,754,308	5/19/98	Lopresti et al.	358	403	
	5,859,935	1/12/99	Johnson et al.	382	317	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	08331362 A	12/13/96	Japan	H04N	1/387	X	
	09037004 A	02/07/97	Japan	H04N	1/00	X	
	9-077365		Japan			X	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

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